

## **ABSTRACT**

There is provided a configuration including; a substrate holder configured to hold a plurality of substrates including product substrates and dummy substrates; a transfer mechanism configured to load the plurality of substrates to the substrate holder; a main controller configured to determine substrate-mounting positions for the plurality of substrates according to setting items respectively corresponding to the number of the product substrates to be mounted on the substrate holder, the number of the dummy substrates to be loaded above and below the product substrates, and a number indicating a mounting position of a topmost of the dummy substrates to be loaded to the substrate holder; and a transfer controller configured to operate the transfer mechanism according to the determined substrate-mounting positions.

FIGURE 5